



**ELECTRONIC COPY**

LG794641545  
Report verification at igi.org



April 21, 2026  
IGI Report Number **LG794641545**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **11.33 X 7.97 X 5.43 MM**  
**GRADING RESULTS**  
Carat Weight **4.52 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**  
Cut Grade **EXCELLENT**

**LABORATORY GROWN DIAMOND REPORT**

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Description **LABORATORY GROWN DIAMOND**  
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MODIFIED BRILLIANT**  
Measurements **11.33 X 7.97 X 5.43 MM**

**GRADING RESULTS**

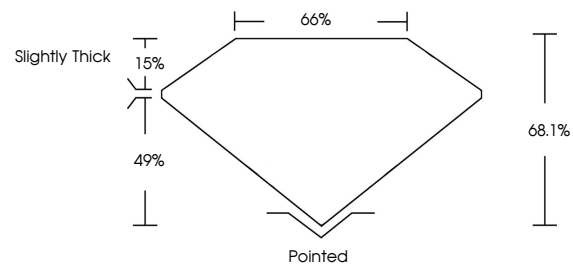
Carat Weight **4.52 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**  
Cut Grade **EXCELLENT**

**ADDITIONAL GRADING INFORMATION**

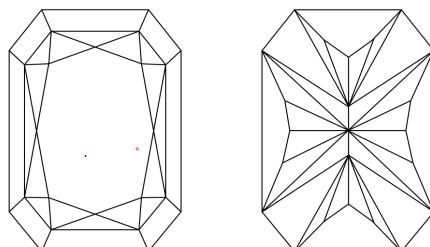
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG794641545**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

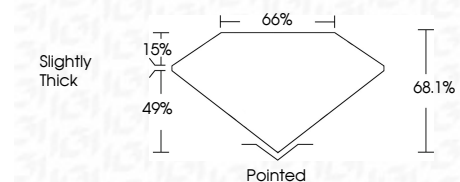
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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CUT CORNERED RECT. MODIFIED BRILLIANT  
11.33 X 7.97 X 5.43 MM  
4.52 CARATS  
F  
VVS 2  
EXCELLENT  
68.1%  
66%  
Slightly Thick  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG794641545  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa